



MEMC 99-0900(2632)  
PATENT

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5/25/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Robert H. Fuerhoff, et al.

Art Unit 1765

Serial No. 09/502,340

Filed February 10, 2000

Confirmation No. 5009

For METHOD OF CONTROLLING DIAMETER OF A SILICON CRYSTAL IN A  
LOCKED SEED LIFT GROWTH PROCESS (as amended by Amendment A)

Examiner M. Anderson

May 17, 2002

**NOTICE OF APPEAL FROM THE PRIMARY EXAMINER  
TO THE BOARD OF PATENT APPEALS AND INTERFERENCES**

RECEIVED  
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TO THE COMMISSIONER OF PATENTS AND TRADEMARKS,  
SIR:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the  
decision of the Examiner dated February 20, 2002, rejecting the following claims: 1-10.

The appeal fee of \$320.00 is submitted herewith.

If there are any additional charges in this matter, please charge our Deposit Account No.  
19-1345.

05/21/2002 AWONDAF1 00000061 9502340

01 FC:119

320.00 OP

Respectfully submitted,

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